

INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com



Equipment Type: 8 and 10-inch diameter Single Grinder / Polisher

Model: **NANO 1000T**

Speed (rpm) 0-1000 rpm

Electrical Requirements: 110 / 220 Volts (single-phase input)

(Power converted to 3-phase for motor - higher torque)

Frequency: 50/60 Hz

Motor Horsepower: 1 hp (750 W)

Manual Revision Date: April 2014

Please read this instruction manual carefully and follow all installation, operating and safety guidelines.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

Contents

		PAGE
Wa	rranty	ii
1.0	Product Description	1
2.0	Unpacking, Shipping and Installation	4
3.0	Safety Guidelines	6
4.0	Start-Up and Operation	8
5.0	Maintenance	20
6.0	Trouble Shooting	21
7.0	Metallographic Consumables	22
8.0	Spare Parts	26
9.0	Schematics	39



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

WARRANTY

Terms and Conditions applying to all PACE Technologies Products

1. LIMITED WARRANTY AND DISCLAIMER:

PACE Technologies Products are warranted for one year from the purchase date to be free from defects in material and workmanship under correct use, normal operating conditions, and proper application. PACE Technologies obligation under this warranty shall be limited to the repair or exchange, at PACE Technologies option, of any PACE Technologies Product or part which proves to be defective as provided herein. PACE Technologies reserves the right to either inspect the product at Buyer's location or require it to be returned to the factory for inspection. Buyer is responsible for freight to and from factory on all warranty claims. The above warranty does not extend to goods damaged or subjected to accident, abuse or misuse after release from PACE Technologies warehouse, nor goods altered or repaired by anyone other than specifically authorized PACE Technologies representatives. PACE Technologies shall not in any way be responsible for the consequences of any alteration, modification or misuse unless previously approved in writing by an officer of PACE Technologies.

PACE TECHNOLOGIES MAKES NO EXPRESS WARRANTIES OTHER THAN THOSE WHICH ARE SPECIFICALLY DESCRIBED HEREIN. Any description of the goods sold hereunder, including any reference to Buyer's specifications and any description in catalogs, circulars and other written material published by PACE Technologies, is the sole purpose of identifying such goods and shall not create an express warranty that the goods shall conform to such description.

THIS WARRANTY IS EXPRESSLY IN LIEU OF ALL OTHER WARRANTIES, EXPRESSED OR IMPLIED. THERE ARE NO IMPLIED WARRANTIES OF MECHANTABILITY OR FITNESS FOR PARTICULAR PURPOSE. THIS WARRANTY STATES PACE TECHNOLOGIES ENTIRE AND EXCLUSIVE LIABILITY AND BUYER'S EXCLUSIVE REMEDY FOR ANY CLAIM FOR DAMAGES IN CONNECTIONS WITH PACE TECHNOLOGIES PRODUCTS. PACE TECHNOLOGIES WILL IN NO EVENT BE LIABLE FOR INCIDENTAL OR CONSEQUENTIAL DAMAGES WHATSOEVER, NOR FOR ANY SUM IN EXCESS OF THE PURCHASE PRICE.

2. LIABILITY CAP:

PACE Technologies maximum aggregate liability for loss and damage arising under, resulting from or in connection with the supply or use of the Equipment and Consumables provided under this purchase, or from the performance or breach of any obligation (s) imposed hereunder, whether such liability arises from any one or more claims or actions for breach of contract, tort, (including negligence), delayed completion, warranty, indemnity, strict liability or otherwise, unless otherwise limited by the terms hereof, shall be limited to one hundred percent (100%) of the purchase price.

3. DELIVERY:

Customer assumes and shall bear the risk of all loss or damage to the Products from every cause whatsoever, whether or not insured, and title to such Products shall pass to Customer upon PACE Technologies delivery of the Products to the common carrier of Pace Technologies choice, or the carrier specified in writing by Customer, for shipment to Customer. Any claims for breakage, loss, delay, or damage shall be made to the carrier by the Customer and Pace Technologies will render customer reasonable assistance in prosecuting such claims.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

4. ACCEPTANCE:

Customer shall inspect the Products promptly upon receipt of delivery. Unless customer objects in writing within thirty (30) business days thereafter, customer shall be deemed to have accepted the Products. All claims for damages, errors, or shortage in Products delivered shall be made by Customer in writing within such five (5) business day period. Failure to make any claim timely shall constitute acceptance of the Products.

5. PAYMENT:

Customer agrees to provide timely payment for the Products in accordance with the terms of payment set forth on the reverse side hereof or in any proposal submitted herewith. If any payment is not paid on or before its due date, Customer shall pay interest on such late payment from the due date until paid at the lesser of 12% per annum or the maximum rate allowed by law.

6. DEFAULT:

If Buyer is in default (including, but not limited to, the failure by Buyer to pay all amounts due and payable to Seller) under the work or purchase order or any other agreement between Buyer and Seller, Buyer's rights under the warranty shall be suspended during any period of such default and the original warranty period will not be extended beyond its original expiration date despite such suspension of warranty rights.

7. MISCELLANEOUS PROVISIONS:

This agreement has been made in and shall be governed by the laws of the State of Arizona. These terms and conditions and the description of the Products on the reverse side hereof or in any proposal submitted herewith constitute the entire agreement and understanding of the parties with respect to this sale and supersede all prior and contemporaneous agreements or understandings, inducements or representations, expressed or implied, written or oral, between the parties with respect hereto. Any term or provision of this Agreement may be amended, and any observance of any term of this Agreement may be waived, only by a writing signed by the party to be bounds. The waiver by a party of any breach shall not be deemed to constitute a waiver of any other breach. Should suit be brought on this Agreement, the prevailing party shall be entitled to recover its reasonable attorneys' fees and other costs of suit including costs and attorneys' fees incurred on appeal or in collection of any judgment.

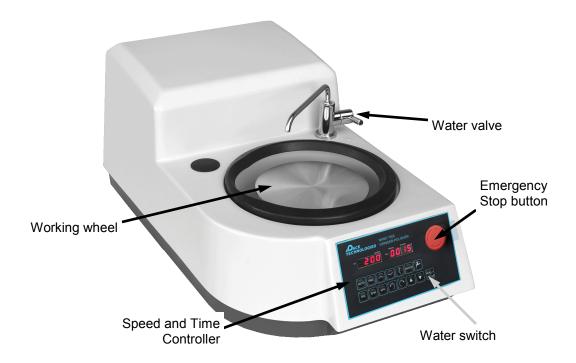


INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

1.0 Product Description

1.1 General Description



The NANO 1000T is a 8 or 12-inch single wheel grinding/ polishing machine for manual wet grinding or polishing of metallographic specimens.

The NANO 1000T is a variable speed (0-1000 rpm) with three programmable fast speed buttons (approx. 100, 200 and 300 rpm) polisher.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

1.2 Technical Specifications

Electrical specifications: 110 / 220V (50/60 Hz) (single phase

input - motor runs on 3-phase power

for more torque)

Working wheel: 8-inch (200 mm) or

10-inch (250 mm) diameter

Motor power: 1 hp (750 W)

Polishing base speed: 0 to 1000 rpm variable speed (20

rpm increments). Fast speed buttons pre-programmed for 100,

200 and 300 rpm)

Weight: Approx. 102 lbs (46 kg)

Dimensions (WxHxD): Approx. 14" x 10" x 23"

(350 mm x 260 mm x 580 mm)

Working temperature: 32° - 100°F (0 - 40°C)

Shipping temperature: 32° - 100°F (0 - 40°C)

Storage temperature: 32° - 100°F (0 - 40°C)

Maximum diameter sample 1/3 diameter of working wheel



INSTRUCTION MANUAL

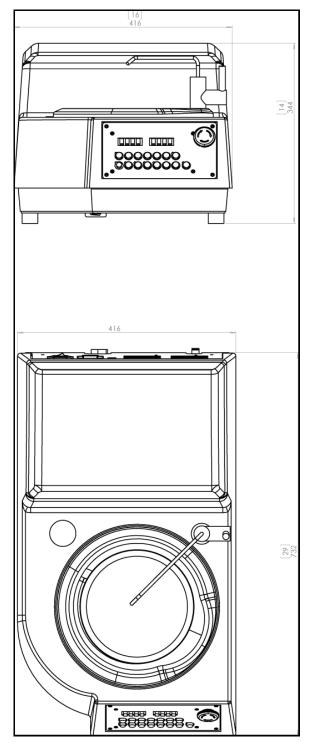
3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

1.3 Mechanical Schematic

Note: Installation of the NANO 1000T should be on a flat sturdy surface, with easy access to drain, water and electrical connections.

1.4 Features

The **NANO 1000T** is equipped with a powerful motor, connected to the polishing wheel through a maintenance-free V-belt.





INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

2.0 Unpacking, Shipping and Installation

2.1 UnpackingUnit is delivered in a box. Unpack and check for completeness of parts.

Measures WxHxD:

Weight: Varies, depending upon model

(approximately).

2.2 Shipping When moving box, lift from bottom.







Caution: Heavy equipment. Take care to avoid bodily injury.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

2.3 Installation

Install unit carefully! Improper installation voids warranty.

The *NANO 1200* should be placed on a flat stable surface. Connect to air, water supply, drain and electrical connections.

After water, drain and electrical connections are completed, the system is ready for operation by activating the main power switch.









Connect drain for best direction to drain with fittings

External water supply: The water supply line requires a 1/4-inch compression fitting. It is

recommended that the water supply be turned off when the unit is not in use. Inlet water should be clean and contamination-free to

extend the life and performance of the systems.

Electrical connection: Connect six-foot electrical power cable to source.

Note: Inspect the operating voltage on the name plate.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

3.0 Safety Guidelines

3.1 Warning Sign

This sign points to special safety features on the machine.

3.2 Safety Precautions

- Careful attention to this instruction manual and the recommended safety guidelines is essential for the safe operation of the **NANO 1000T**.
- Proper operator training is required for operation of the *NANO 1000T*. Any unauthorized mechanical and electrical change, as well as improper operation, voids all warranty claims. All service issues need to be reported to the manufacturer / supplier.
- Operate unit as specified in this manual.
- Disconnect power before opening unit.
- Do not leave any specimen or other parts on the working wheel.
- Ensure that the air slots on polishing base are not obstructed.
- When unit is not in use turn off water.
- Securely hold the sample, preferably with two hands.

3.3 Emergency Statement

The NANO 1000T polisher has been designed for polishing metallographic specimens up to 2-inch diameter. DO NOT GRIND OR POLISH oversize sample (greater then 1/3 diameter of working wheel. Always follow proper operational guidelines and avoid contact with moving parts, lubricants and abrasives. Seek appropriate medical care for cutting injuries.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

3.4 Safety Test

Examine and verify that the **NANO 1000T** safety devices and operating performance are in good working condition prior to use. The following safety check is considered important:



Emergency stop switch

Test: Activate main switch.

Depress emergency stop switch.

Proper

Response:

Machine powers down.

Malfunction: Machine does not lose power.

Corrective If system does not power down,

measure: disconnect power supply cord and call

service technician.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

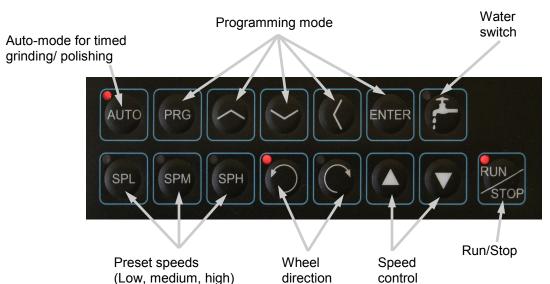
4.0 Start-up and Operation

4.1 General

The **NANO 1000T** is a hand grinding/polishing machine. By adding the FEMTO power head, semi-automated polishing can be



4.2 Control Panel



Emergency stop button: Emergency stop switch cuts power to the motor immediately.

Wheel direction: Clockwise rotation and counter clockwise rotation.

Run / stop buttons: Start/stop the polishing wheel in both manual and auto mode.

Water switch: Activates the water solenoid for the rinse bowl and rinse spout.

Preset speeds: Allows for faster speed control, SPL - low speed, SPM - medium

speed, SPH - high speed (factory setting approx. 100, 200, 300

rpm.

Auto-mode: Allows for running pre-programmed speeds and times (factory

setting approx. 200 rpm, FWD, 30 seconds).



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

4.2.1 Direction and speed controller (manual)

- 1. To change direction of the wheel:
 - -Press clockwise or counter clockwise button, LED will light
- 2. To change the speed of the wheel:

Select low, medium or high speed fast buttons and use up and down arrows to fine tune speed if required

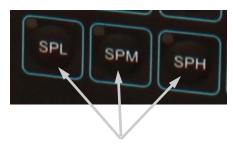
4.2.1 Programmable Mode

- The programming mode can be used to pre-set the polishing speed, direction and time for automated polishing. It can also be used to change the fast speed buttons.
- 2 To change the speed of the wheel:
 - Press the PRG button and use the up and down keys to SP1 and press ENTER. Use the up and down < key to change the speed. Press ENTER to save.
- 3 To program a grinding/ polishing time:
 - Press the PRG button and use the up and down keys to t1 and press ENTER. Use the up and down < key to change the time (enter in seconds displayed min-sec)
- 4 To operate the pre-programmed conditions:

PRESS the AUTO button and then start the program with the RUN/STOP button. The pre-programmed conditions will be executed.

4.3 Grinding / polishing by hand

- 1. Install working wheel and attach grinding papers / polishing cloths.
- 2. Switch on the machine in the back and set the mode, speed, and time (if required).
- 3. Position flexible water spout over working wheel. During sample preparation adjust water flow by turning water control knob as required. Note: Initial operation of water valve may contain air in the lines. Turn water on slowly to purge air from system.
- 4. Press RUN/STOP start and stop the machine in the manual mode.



Fast speed buttons

To change the speed setting for the fast speed buttons use the following procedure:

Press the PRG button and use the up and down keys to SL (slow speed) and press ENTER. Use the up and down < key to change the speed. Use Sn for changing the medium speed and SH for the fast speed.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

4.4 Metallographic Specimen Preparation Basics

A typical metallographic specimen preparation consists of the following basic steps:

<u>Preparation Stage</u>	<u>Purpose</u>
Initial documentation:	 To document the initial condition of the sample, To map the sample surface, To highlight the area of interest.
Sectioning / cutting:	 To reduce the size of large samples and to sample the specimens close to the area of interest.
Rough, or planar grinding:	 To obtain a planar surface, To remove sectioning damage, To approach the area of interest.
Rough polishing:	 Ideally to remove all the subsurface damage and microstructural damage produced during cutting and rough grinding (Superficial scratches may still be present after this step).
Final polishing:	 Generally, more for cosmetic purposes than for removing microstructural damage. In most cases, this stage should be minimized to avoid overpolishing and distorting the microstructural features.
Etching:	 To enhance microstructural features such as grain boundaries, grain size, phase differences, etc.
Examination:	 A variety of examination techniques are used in metallography, including: optical microscopy, electron microscopy and hardness testing.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

4.4.1 Rough / Planar Grinding

Rough or planar grinding, is required to produce flat specimens and to reduce the damage created by sectioning. The planar grinding step is accomplished by decreasing the abrasive grit particle size sequentially to obtain surface finishes that are ready for polishing. Care must be taken to avoid being too abrasive in this step, and actually creating greater specimen damage than produced during cutting. This is especially true for very brittle materials such as ceramics and silicon.

The machine parameters which affect the preparation of metallographic specimens include: grinding / polishing pressure, grinding direction, and the relative velocity distribution between the specimen and the polishing wheel.

Grinding Pressure

Grinding / polishing pressure is dependent upon the applied force (pounds or Newton's) and the area of the specimen and mounting material. Pressure is defined as the Force/Area (psi, N/m² or Pa). For specimens significantly harder than the mounting compound, pressure is better defined as the force divided by the specimen surface area. Thus, for larger hard specimens, higher grinding / polishing pressures increase stock removal rates. However, higher pressure also increases the amount of surface and subsurface damage produced in the specimen.

Note regarding SiC grinding papers: as the abrasive grains dull and cut rates decrease, increasing grinding pressures can extend the life of the SiC paper.

Higher grinding / polishing pressures can also generate additional frictional heat which may be beneficial for the chemical mechanical polishing (CMP) of ceramics, minerals and composites. Likewise for extremely friable specimens (such as nodular cast iron), higher pressures and lower relative velocity distributions can aid in retaining inclusions and secondary phases.

Grinding Direction

The orientation of the specimen can have a significant impact on the preparation results, especially for specimens with coatings. In general, when grinding and polishing materials with coatings, the brittle component should be kept in compression. In other words, for brittle coatings, the direction of the abrasive should be through the coating and into the substrate. Conversely, for brittle substrates with ductile coatings, the direction of the abrasive should be through the brittle substrate and into the ductile coating.

Manual Preparation

In order to ensure that the previous rough grinding damage is removed when grinding by hand, the specimen should be rotated 90 degrees and continually ground until all of the scratches from the previous grinding direction are removed. When necessary, the abrasive paper should be replaced with a newer paper to maintain cutting rates.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

4.4.2 Rough Polishing

The purpose of the rough polishing step is to remove the damage produced during cutting and planar grinding. Proper rough polishing will maintain specimen flatness and retain all inclusions or secondary phases. By eliminating the previous damage and maintaining the microstructural integrity of the specimen at this step, a minimal amount of time is required to remove the cosmetic damage at the final polishing step.

Rough polishing is accomplished primarily with diamond abrasives ranging from 9 micron to 1 micron. Polycrystalline diamond - because of its multiple and small cutting edges - produces high cut rates with minimal surface damage. Therefore, polycrystalline diamond abrasives are recommended for metallographic rough polishing on low-napped polishing cloths.

Rough Polishing Guidelines

Material	Recommendations	
Metals (ferrous, non-ferrous, tool steels, superalloys, etc.)	Rough polishing typically requires two polishing steps, e.g., a 6-micron diamond followed by a 1-micron diamond on low-napped polishing cloths.	
Ceramics and ceramic matrix composites (CMC)	Low-nap polishing pads using polycrystalline diamond, alternating with colloidal silica. This provides a chemical mechanical polishing (CMP) effect which results in a damage-free surface	
Polymer matrix composites (PMC)	Diamond-lapping films are recommended.	
Biomaterials	Low-napped polishing pads with polycrystalline diamond, alternating with colloidal silica. Alternatively, diamond-lapping films may work well.	
Microelectronic specimens	Diamond-lapping films are recommended.	
Plastics and polymers	800 and 1200 grit SiC abrasive paper are recommended.	
Plasma spray materials	Diamond-lapping films or low-napped polishing pads with alternating diamond and colloidal silica abrasives.	



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

4.4.3 Final Polishing

The purpose of final polishing is to remove only the cosmetic surface damage. It should not be used to remove any damage remaining from cutting and planar grinding. If the damage from these steps is not completely removed, the rough polishing step should be repeated or continued.

Final Polishing Guidelines

Material	Recommendation
Metals (ferrous, non- ferrous, tool steels, superalloys, etc.)	High-napped polishing pads with a nanometer alumina polishing abrasive. The polishing times should nominally be less than 30 seconds.
Ceramics and ceramic matrix composites (CMC)	Low-napped polishing pads using 1-um polycrystalline diamond, alternating with colloidal silica or colloidal silica alone.
Polymer matrix composites (PMC)	Fine abrasive diamond-lapping films, followed by a very light polish on a high-napped polishing pad.
Biomaterials	Low-napped polishing pads with polycrystalline diamond, alternating with colloidal silica.
Microelectronic specimens	Diamond-lapping films followed by a very light polish on a high-napped polishing pad.
Plastics and polymers	Light polish with alumina on a high-napped polishing pad.
Plasma spray materials	Diamond-lapping films followed by a very light and short alumina or colloidal silica polish on a high-napped polishing pad.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

4.5 Selected Polishing Procedures

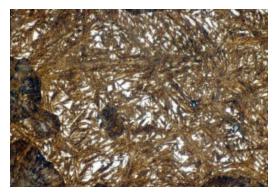
4.5.1 1095 Carbon Steel (Pearlite and Martensite Phases) Preparation of high carbon steels is fairly straight-forward. Depending upon the heat treatment, the grinding and polishing times may increase for the harder martensite phase.

Abrasive/surface	Lubricant	Time
PDGD-125M Diamond Grinding Disk	water	Until plane
SIRIUS Composite grinding disk	9 um DIAMAT Diamond	3 minutes
ORION Composite grinding disk	3 um DIAMAT diamond	3 minutes
1 um DIAMAT diamond on ATLANTIS pad	DIALUBE Extender	2 minutes
0.05 um Nanometer alumina on MICROPAD or TRICOTE pad		1 minute



1095 Steel, Furnace-Cooled, etched with 2% nital, 400X B.F.

Microstructure: Pearlite structure



1095 Steel, Water-Quenched, etched with picric acid, 1000X B.F. Miicrostructure: Martensite structure



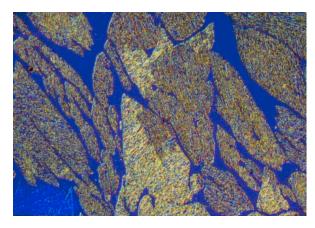
INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

4.5.2 Stainless Steel

Stainless steels have high concentrations of chromium (>12%) and are generally relatively soft as compared to heat-treated steels. This makes stainless steel more susceptible to smearing. Preparation is relatively straight-forward.

Abrasive/surface	Lubricant	Time
320 grit SiC paper 400 grit SiC paper 600 grit SiC paper 800 grit SiC paper 1200 grit SiC paper	water	Until plane 1 minute 1 minute 1 minute 1 minute 1 minute
1 um DIAMAT diamond on TEXPAN pad	SIAMAT colloidal silica	2 minutes
0.05 um Nanometer alumina on NAPPAD pad		1 minute



431 Stainless Steel microstructure



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

4.5.3 Aluminum and Aluminum Alloys

Aluminum and aluminum alloys are difficult to prepare because they are soft and contain oxide particles which can become dislodged and scratch the surface. The key to polishing aluminum is to use very fine polishing abrasives (fine aggregates).

Abrasive/surface	Lubricant	Time
P220 grit ALO paper P500 grit ALO paper P1200 grit ALO paper	Water	Until plane 1 minute 1 minute
1 um DIAMAT diamond on ATLANTIS pad	DIALUBE Purple Extender	2 minutes
0.05 um Nanometer alumina on NAPPAD pad		1 minute



Aluminum - Silicon Alloy microstructure, Kallings etchant



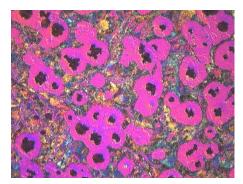
INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

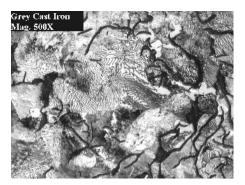
4.5.4 Cast Iron

Cast irons are difficult materials to prepare properly because the graphite nodules (or graphite flakes) are easily pulled out during preparation. By minimizing the sectioning damage and by starting with a modest-grit-size SiC paper, retaining these difficult particles can be accomplished.

Abrasive/surface	Lubricant	Time
320 grit SiC paper 400 grit SiC paper 600 grit SiC paper 800 grit SiC paper 1200 grit SiC paper	water	Until plane 1 minute 1 minute 1 minute 1 minute 1 minute
1 um DIAMAT diamond on GOLDPAD pad	DIALUBE Purple Extender	3 minutes
0.05 um Nanometer alumina on TRICOTE pad		1 minute



Nodular Cast Iron microstructure, Etchant 2% nital, Mag. 100X



Graphite Cast Iron microstructure, Etchant 2% nital, Mag. 500X



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

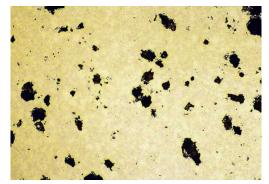
4.5.5 Alumina Ceramic

The preparation of hard / brittle / porous ceramic materials is not especially difficult when a few simple preparation tricks are known for this class of materials. First, to minimize grain pull-out (which may be falsely characterized as porosity), sectioning damage must be minimized. This is accomplished by sectioning with the appropriate diamond wafering blade and using the finest practical abrasive for initial grinding.

Planar grinding is best achieved with the use of the smallest diamond abrasive possible on a metal mesh cloth. Note that there is a trade-off between planar grinding time (abrasive size) and induced damage. In some cases for ceramics, it is better to take more time and minimize damage at planar grinding in order to reduce overall polishing times.

The use of SIAMAT™ colloidal silica also provides a chemical mechanical polishing (CMP) action, which is the most effective means for eliminating both surface and subsurface damage. The combination of SIAMAT™ colloidal silica with a DIAMAT™ polycrystalline diamond also produces excellent surface finishes.

Abrasive/surface	Lubricant	Time
30 um DIAMAT diamond on CERMESH metal mesh cloth		Until plane
6 um DIAMAT diamond on TEXPAN polishing pad	SIAMAT colloidal silica	5 minutes
1 um DIAMAT diamond on GOLDPAD polishing pad	SIAMAT colloidal silica	5 minutes
SIAMAT Colloidal silica on TEXPAN pad		5 minutes



85% Alumina microstructure, 500X (note the sharp edges - edge retention)



99+% Alumina microstructure, 5000X (thermally etched)

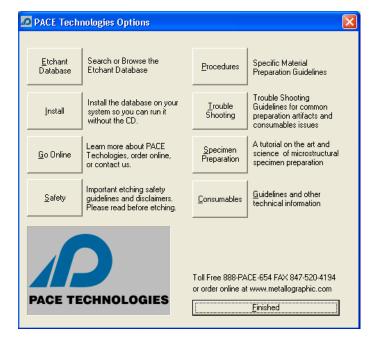


INSTRUCTION MANUAL

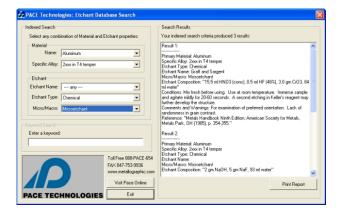
3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

Educational Etchant and Procedure Database CD (optional)

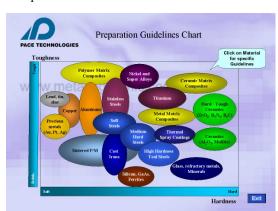
- Etchant Database OVER 2200 ETCHANTS
- Search Fields
 - Material or metal type
 - Specific alloys
 - Etchant name
 - Micro vs. Macro etchant
 - Keyword
- MSDS for Etchant Chemicals
- Preparation Guidelines
- Preparation Basics
- Preparation Trouble Shooting



Etchant Database



Preparation Guidelines





INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

5.0 Maintenance

5.1 Introduction

The **NANO 1000T** requires very minimal maintenance. However, to increase the life of the polisher, it is suggested that the unit be rinsed after use.

5.2 Cleaning outside cabinet

The cabinet should be cleaned occasionally with a moistened cloth. Do not use any chemicals or cleaning abrasives.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

6.0 Trouble Shooting

More extensive trouble shooting, repair guides, video's, parts list are provided online at www.metallographic.com or

http://www.metallographic.com/PACE-service/NANO-service.html

Problem	Cause	Solution
No power or function	a. Unit is disconnected from main electrical power supplyb. Main power switch is offc. Blown fuse	a. Verify electrical source and connection.b. Turn on main power switch.c. Replace fuse
No water supply	a. Water valve closed b. Water tube is extremely bent	a. Open valve b. Straighten out water tube.
Working wheel is not running plane (flat)	a. Dirt (abrasive between working wheel and carrier wheel)	a. Clean or replace if necessary.
Error Message E1	a. Motor power surge.	a. Turn polisher off and wait until LED discharges. Turn unit back on, if problem persist contact PACE service department

Pry open fuse holder with small flat head screwdriver





Replace fuse (10 amp fast blow)

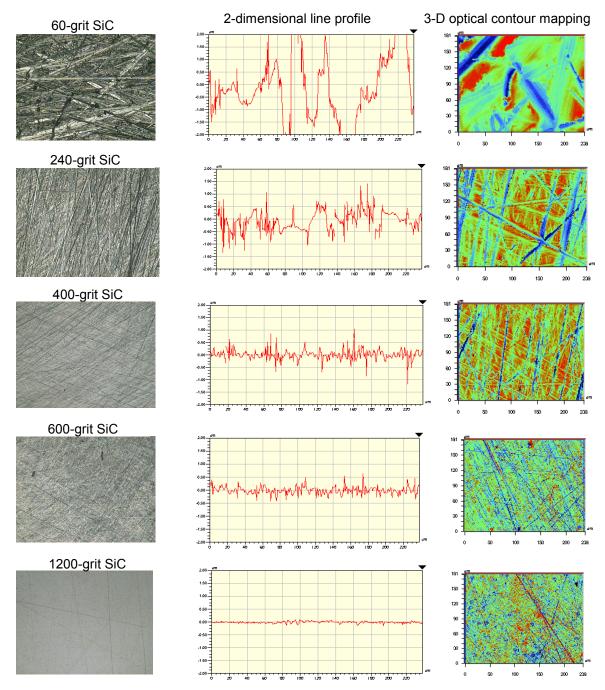


INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

7.0 Metallographic Consumables

7.1 SiC Abrasive Paper, Surface Roughness





INSTRUCTION MANUAL

7.3 Polishing Pads

7.6 Tolloring Fudo			
	Metal Mesh Cloth. This is a wire mesh material useful for coarse and intermediate lapping / polishing. The texture of this wire allows for the abrasive to become semi-fixed, thus offering the advantage of increased stock removal, while minimizing damage.		
	POLYPAD™ Polishing Pad. This cloth is a synthetic polyester polishing pad which has a similar action to a nylon pad, except that it is much more durable. It is used in the intermediate polishing steps.		
	TEXPAN Polishing Pad. This is the most commonly used polishing cloth material for the intermediate polishing steps. TEXPAN™ Polishing pad is a lownapped cloth.		
	Black CHEM™ 2 Polishing Pad. This porometric polymer pad has the consistency similar to a rubber type of pad. Black CHEM™ 2 pad has a low nap but behaves as an intermediate polishing pad with a performance between low-napped and high-napped pads.		
HIM HO	GOLDPAD Polishing Cloth. This is a woven low- napped polishing pad used mostly for intermediate diamond polishing for ceramics and metals and polymers.		
	ATLANTIS Polishing Cloth. This polishing pad is a laminated polishing cloth having a resilient foam backing. The foam backing allows the polishing to conform better to the specimen surface.		
	MICROPAD™ and MICROPAD™ 2 Polishing Cloth. This is the most commonly used high-napped final polishing cloth for metals and polymers. Its high nap provides a very soft and gentle polishing action.		
	NAPPAD™ Polishing Pad. This is another high-napped final polishing pad useful for most metals and polymers. It has a higher nap than MICROPAD™, providing the most gentle polishing action of all the cloths.		



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

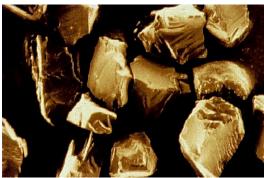
7.4 Polycrystalline Diamond Abrasives

Polycrystalline diamond is a synthetic diamond which provides better surface finishes and higher removal rates than monocrystalline diamond. The following are the advantages of a polycrystalline diamond over a monocrystalline diamond:

- Higher removal rates (self-sharpening abrasive)
- Very uniform surface finish
- More uniform particle size distribution
- Harder / tougher particles
- Blocky shaped particles
- Hexagonal (equally hard in all directions) microcrystallites
- Extremely rough surface (more cutting points)
- Surface area is 300% greater than with a monocrystalline diamond
- No abrasion-resistant directionality (abrasion independent of particle orientation)

Diamond Size (um)	Color code
0.10	Charcoal
0.25	Gray
0.50	White
1.0	Blue
3.0	Green
6.0	Yellow
9.0	Red
15	Brown
30	Orange
45	Purple





Monocrystalline blocky - diamond



Polycrystalline multi-faceted diamond



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

7.5 Final Polishing Abrasives





Final polishing abrasives include fine diamond, alumina and colloidal silica. For successful microstructural preparation, the polishing abrasive / cloth combination must be appropriately matched to the specimen hardness, fracture toughness and corrosion properties of the specimen.

Colloidal Silica

Colloidal silica is a relatively soft abrasive with high chemical activity. It is an ideal chemical mechanical polishing (CMP) abrasive. The chemical activity of colloidal silica results from the electrochemical balance (zeta potential) required to keep very fine particles from aggregating. This chemical balance also produces a surface phenomenon which makes the specimen surface more chemically active. This produces a surface layer which can be mechanically removed by the colloidal silica particles themselves, or by the mechanical scrubbing of the surface with the polishing pad.

For ceramics, the combination of fine polycrystalline diamond and colloidal silica improves surface finishes and increases polishing rates.

Nanometer Alumina

Nanometer alumina is a polycrystalline colloidal alumina processed by a proprietary seeded gell process. Polycrystalline alumina offers two significant improvements over conventional alumina calcining processes:

- 1. Tighter, more controlled particle size distributions
- 2. Harder alpha alumina particles

The tighter, more controlled particle size distribution is a result of less particle aggregation which produces significantly less scratching in soft metals, such as aluminum, tin, lead, copper and soft steels.

Nanometer alumina is available in an acidic (pH 4) or basic (pH 10) range.

Please read this instruction manual carefully and follow all installation, operating and safety guidelines.



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

8.0 Spare Parts

Part no.	Description	Images
	Electrical	
N1-007b	NANO 1000T and 2000T Motor (750 W - 1 hp)	Packotak
N1-007c	NANO 1200T Motor (1.5 hp)	PACE DO LES
N1-008b	NANO 1000T/2000T PC board / frequency convertor (new machine using 24V transformer)	Act Loads And Loads And Act Lo
N1-008c	NANO 1200T PC board / frequency convertor (new machine using 24V transformer)	DACE LOCALES THE PARTY OF THE P
N1-008T	PC board (top only) for 1 rpm increments	Paradore



INSTRUCTION MANUAL

Part no.	Description	Images
	Electrical	
N1-012b	Transformer (24V)	TOO SERVICE SALES OF THE SERVI
N1-013	Emergency Stop	and the second s
N1-015b	Front Panel (with time display) with PC board	
N1-015c	Front panel connection cable (with time display)	
FUSE-C	Controller T6.3A fuse - (each)	Quinter.
FUSE-NA	10 amp fuse for NANO Polishers (3/package)	PACE FECHIOLOGIES
PS-001	On/Off switch	
24RELAY	24 volt relay switch	Schrieber Schrieber



INSTRUCTION MANUAL

Part no.	Description	Images
	Electrical	
RELAY-B	24 volt relay switch base	Appendix Control of the Control of
NANO-R	Rectifier	
N1-009b	Solenoid Valve (24 V)	Park Control of the C
CORD-110V	110V power cord	Orthodom P
CORD-220R	220V round time power cord	
CORD-220F	220V three prop flat connector	



INSTRUCTION MANUAL

Part no.	Description	Images
	Mechanical Components	
PW-800	NANO 1000-2000 8-inch working wheel	
PW-1000	NANO 1000-2000 10-inch working wheel	Que de la constante de la cons
PW-1200	NANO 1200 12-inch working wheel	The state of the s
PW-1400	NANO 1200 14-inch working wheel	
N1-001	NANO 1000 Single Wheel FRP cover	Ace o course
N2-001	NANO 2000 Double Wheel FRP cover	Pace OLOGIES TECHNOLOGIES TECHNOLOGIES
N12-001	NANO 1200 FRP cover	ACE CLOCKES TECHNOLOGICAN TECHNOLOGICAN
N1-002	NANO 1000-2000 Polishing Table Support Platen	O. Agricultural Control of the Contr



INSTRUCTION MANUAL

Part no.	Description	Images
	Mechanical Components	
N12-002	NANO 1200 Polishing Table Support Platen	- And Supplement
N1-002PEG	Table support PEG's without o-rings (3/set)	
N1-002-O-Ring	Table support PEG O-ring (3/pkg)	80
N1-003S	NANO 1000T/2000T Spindle assembly	Postor of the Control
N1-025	FEMTO 1100 post collar (mounts on the NANO 1000-2000 polisher)	
N1-003P	NANO 1000-2000 Pulley wheel for spindle wheel	Garden Communication of the Co
N1-006	NANO 1000-2000 Pulley for motor	PACE OLOGIES FECTIVE DESCRIPTION



INSTRUCTION MANUAL

Part no.	Description	Images
	Mechanical Components	
N1-005	NANO 1000T Single Wheel Belt	PACE OLOGIES, ME TECHNOLOGICAL COMMENTAL COMME
N2-005	NANO 2000T Double Wheel Belt	Protection of the state of the
N12-005	NANO 1200T Single Wheel Belt	ACE OLO GIES FECHNOLOGICANIA THE CONTROL OF THE CON
PTM-125-005	8-inch plain backed paper ring	
PTM-125-006	10-inch plain backed paper ring	PACE CLOCKES
PTM-225-005	12-inch plain backed paper ring	" A TO
PTM-225-006	14-inch plain backed paper ring	
PTM-125-007	8 and 10-inch polisher cover	
PTM-225-007	12 and 14-inch polisher cover	Picture Cont.
PTM-225-007H	Cover handle	



INSTRUCTION MANUAL

Part no.	Description	Images
	Mechanical Components	
PTM-125-001	8 and 10-inch splash guard	Bittions
PTM-125-207	12 and 14-inch splash guard	PACE OLOGIES RECHTOR OF THE COLOR
FT-004	Feet (4/pkg)	Pack of the second of the seco
N1-T	NANO 1000T Template	CONTRACTOR STATE OF THE PARTY O
N2-T	NANO 2000T Template	Manage Ma
N12-T	NANO 1200T Template	
N1-M-001	NANO 1000 Casting	



INSTRUCTION MANUAL

Part no.	Description	Images
	Mechanical Components	
N2-M-001	NANO 2000 casting	
N12-M-001	N1200 casting	
N1-M-002	Plastic cover	April a come.
N1-M-003	Femto slot holder	Questione C
N1-M-004	NANO 1000 Bottom cover	
N2-P-BC	NANO 2000 Bottom cover	



INSTRUCTION MANUAL

Part no.	Description	Images
	Mechanical Components	
N12-BOT	NANO 1200 plastic bottom cover	Ace Locies Ferting
N1-M-008	NANO 1000T Motor holder	Peckhologies.
N2-M-003	NANO 2000T Motor holder	
N12-M-003	NANO 1200 Motor holder	Protion of the second
N1-014b	NANO 1000 rear panel	Anticonstitution
N2-M-002	NANO 2000 rear panel	



INSTRUCTION MANUAL

Part no.	Description	Images
	Mechanical Components	
N12-BP	NANO 1200 rear panel	And the same of th
N1-M-007	Front Panel for NANO 1000T/1200T/2000T Polisher (each)	
N1-M-005	Solenoid bracket	Per du de la constante de la c
N1-M-006	Water adapter bracket	Procedure C
N1-M-009	Water hose clamp	Rectification and the second



INSTRUCTION MANUAL

Part no.	Description	Images
	Mechanical Components	
N12-M-002	NANO 1200 Spindle	Actinguages .
N12-M-004	NANO 1200 Wheel pulley	
N12-M-CR	NANO 1200 copper ring	A STATE OF THE STA
N12-M-005	NANO 1200 Spindle shaft	Per de la constante de la cons
N12-M-SSA	NANO 1200 Spindle shaft adapter	Pace of the control o
N12-M-RSH	NANO 1200 roller shaft housing	



INSTRUCTION MANUAL

Part no.	Description	Images
	Plumbing Components	
W-6M	6 mm diameter water supply hose connector	For Form
W-E-8MM	Elbow 8mm quick water connector	
W-S-8MM	8mm water split quick connector	
P-Drain	Drain hose (~2 meters)	
P-Inlet	Water inlet hose (~2 meters)	
N-P-CFA	Copper female adapter	
N1-010	Drain connector set (elbow, nipple, hose barb)	



INSTRUCTION MANUAL

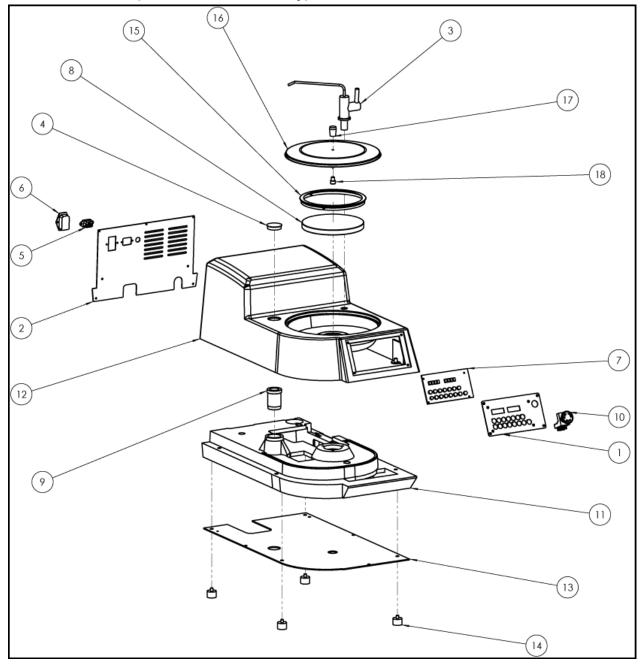
Part no.	Description	Images
	Plumbing Components	
N2-009	NANO 2000 Drain T-fitting	Par Cookes
D-REDUCER	Drain Reducer	Quinta Louis
D-ELBOW	Drain elbow	
D-NIPPLE	Drain-nipple	
D-BARB	Drain hose barb	
P-RINSE	Rinse bowl water sprayer	
P-ADAPTER	Rinse bowl water connector	
PVL	Water value (right side) - single unit and right side double	PACE OLOGIES TECHNOLOGIAN OF THE CONTROL OF THE CON
PVR	Water value (left side) - double unit only	



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

9.0 Schematics (NANO case assembly)





INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

9.0 Schematics (NANO case assembly)

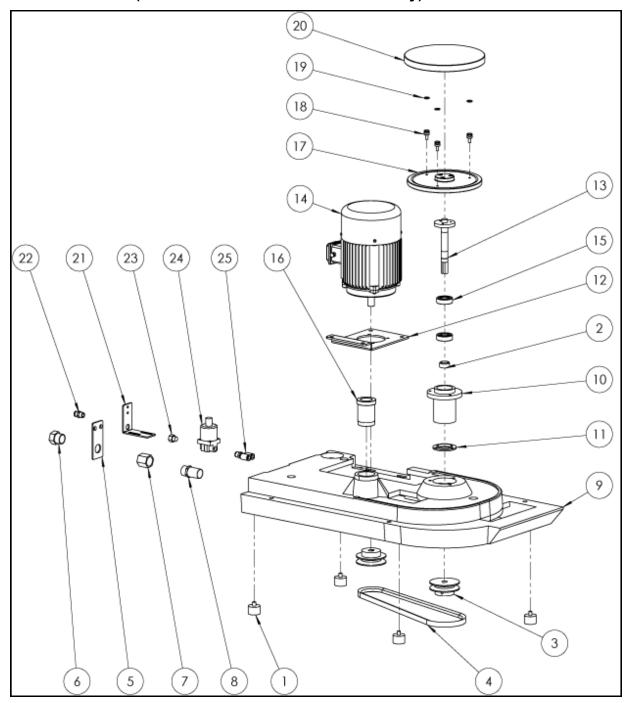
ITEM NO.	PART NUMBER	DESCRIPTION	QTY.
1	N1-M-007	Front panel	1
2	N1-014B	Back panel	1
3	PVR	Water valve right side	1
4	N1-M-002	Plastic cover	1
5	IEC INLET	IEC female	1
6	PS-001	ON/OFF switch	1
7	N1-015B	PC board	1
8	PW-800	8-inch wheel	1
9	N1-025	FEMTO post colar	1
10	P150-210	Emergency switch	1
11	N1-M-001	NANO 1000 Casting	1
12	N1-001	NANO 1000 FRP cover	1
13	N1-M-004	NANO 1000 bottom cover	1
14	FT-004	Rubber Feet	4
15	PTM-125-005	8-inch plain backed paper ring	1
16	PTM-225-007	Polisher cover	1
17	PTM-225-007H	Cover handle	1
18	PTP-S1-01 (M10X12)	M10x12 socket screw	1



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

9.1 Schematics (NANO internal mechanical assembly)





INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

9.1 Schematics (NANO internal mechanical assembly)

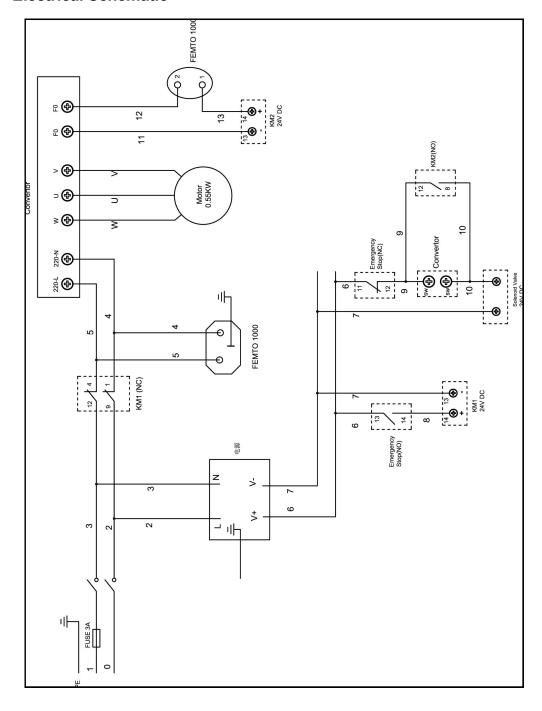
ITEM NO.	PART NUMBER	DESCRIPTION	QTY.
1	FT-004	Rubber Feet	4
2	N1-M-CR	NANO 1000 copper ring	1
3	N1-003P	N1-003P	2
4	N1-005	NANO 1000 single wheel belt	1
5	N1-M-006	Water adapter bracket	1
6	D-REDUCER	Drain reducer	1
7	N-P-CFA	Copper female adapter	1
8	D-BARB	Drain hose barb	1
9	N1-M-001	NANO 1000 casting	1
10	N1-003S3	NANO 1000 spindle shaft housing	1
11	N1-M-SSA	NANO 1000 spindle shaft adapter	1
12	N1-M-008	NANO 1000 Motor holder	1
13	N1-003S-1	NANO 1000 spindle shaft	1
14	N1-007B	NANO 1000-2000 Motor	1
15	N1-M-BEARING	NANO 1000 spindle shaft bearing	2
16	N1-025	FEMTO post colar	1
17	N1-002	NANO 1000 polishing table support platen	1
18	N1-002PEG	Table support PEG's	3
19	N1-002-O-RING	Table support PEG's O-ring	3
20	PW-800	8-inch wheel	1
21	N1-M-005	Solenoid bracket	1
22	W-8MM	8mm water supply hose connector	1
23	D-REDUCER-B	Water reducer	1
24	N1-009B	24V solenoid valve	1
25	W-S-8MM	8mm water split quick connector	1



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

9.3 Electrical Schematic



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

9.1 Full Programming Parameters

NANO 1000T/2000T and 1200T with 20 rpm increments (1 and 1.5 hp motor)

Note:

Do not start or run the motor before the correct input voltage is programmed;

RESET DEFAULT BEFORE REPROGRAMMING

Go to dF \rightarrow Enter \rightarrow -def \rightarrow Enter

Steps to set converter input voltage and frequency response:

```
Go into Program "U" (Password:0253) → Enter → input "1001" →Enter → input "2020" → Enter → input "3030" →Enter→ input "4170" →Display "OVER" →Enter
```

Go into Program "U" (Password:0253)
$$\rightarrow$$
 Enter \rightarrow input "1030" \rightarrow Enter \rightarrow input "2170" \rightarrow Enter \rightarrow input "3050" \rightarrow Enter \rightarrow input "4255" \rightarrow Display "OVER" \rightarrow Enter

Go into Program "U" (Password:0253)
$$\rightarrow$$
 Enter \rightarrow input "1050" \rightarrow Enter \rightarrow input "2225" \rightarrow Enter \rightarrow input "3120" \rightarrow Enter \rightarrow input "4255" \rightarrow Display "OVER" \rightarrow Enter

- 2. Go into Program "nS" (Password:0253) \rightarrow Enter \rightarrow input "2" \rightarrow Enter
- 3. Go into Program "Sr" (Password:0253) → Enter → input "1.4" → Enter

Steps to set converter input voltage and frequency response:

FOR 110V

```
Go into Program "U" (Password:0253) \rightarrow Enter \rightarrow input "1001" \rightarrowEnter \rightarrow input "2025" \rightarrow Enter \rightarrow input "3050" \rightarrowEnter \rightarrow input "4255" \rightarrowDisplay "OVER" \rightarrowEnter
```

Go into Program "U" (Password:0253)
$$\rightarrow$$
 Enter \rightarrow input "1050" \rightarrow Enter \rightarrow input "2255" \rightarrow Enter \rightarrow input "3120" \rightarrow Enter \rightarrow input "4255" \rightarrow Display "OVER" \rightarrow Enter

FOR 220V

```
Go into Program "U" (Password:0253) \rightarrow Enter \rightarrow input "1001" \rightarrowEnter \rightarrow input "2025" \rightarrow Enter \rightarrow input "3050" \rightarrowEnter \rightarrow input "4225" \rightarrowDisplay "OVER" \rightarrowEnter
```

```
Go into Program "U" (Password:0253) \rightarrow Enter \rightarrow input "1050" \rightarrowEnter \rightarrow input "2225" \rightarrow Enter \rightarrow input "3120" \rightarrowEnter \rightarrow input "4225" \rightarrowDisplay "OVER" \rightarrowEnter
```

- 2. Go into Program "nS" (Password:0253) → Enter → input "2" → Enter
- 3. Go into Program "Sr" (Password:0253) \rightarrow Enter \rightarrow input "1.4" \rightarrow Enter



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

NANO 1000T/2000T and 1200T with 20 rpm increments (1 and 1.5 hp motor)

Programming Step	Value	Description
SR	1.4	Belt ratio - DO NOT CHANGE (Enter PW 0253 to access)
SP1	SPEED	Disc Speed - VARIABLE
T1	TIME	Runtime for SP1
SP2 to SP8	200	Multiple step disk speed - DO NOT CHANGE
T2 to T8	0	Runtime for multiple steps - DO NOT CHANGE
CN	1	Number of cycles – DO NOT CHANGE
SL	100	Disc speed for SPL - preset to 100 rpm
SN	200	Disc speed for SPM - preset to 200 rpm
SH	300	Disc speed for SPH - preset to 300 rpm
DF		Defaults—DO NOT CHANGE
U		SET 110/220V—DO NOT CHANGE
ST	65	Shutoff motor temperature - DO NOT CHANGE
СТ		Current motor temperature - DO NOT CHANGE
CD1	0	Controlled by RUN/STOP button - DO NOT CHANGE
CD2	10	Display speed - DO NOT CHANGE

INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

NANO 1000T/2000T and 1200T with 1 rpm increments (1 and 1.5 hp motor)

Note

Do not start or run the motor before the correct input voltage is programmed;

RESET DEFAULT BEFORE REPROGRAMMING

Go to dF \rightarrow Enter \rightarrow -def \rightarrow Enter

Steps to set converter input voltage and frequency response:

```
Go into Program "U" (Password:0253) → Enter → input "1001" →Enter → input "2042" → Enter → input "3050" →Enter→ input "4255" →Display "OVER" →Enter
```

Go into Program "U" (Password:0253) → Enter → input "1050" →Enter → input "2225" → Enter → input "3120" →Enter → input "4255" →Display "OVER" →Enter

- 2. Go into Program "nS" (Password:0253) → Enter → input "2" → Enter
- 3. Go into Program "Sr" (Password:0253) → Enter → input "1.4" → Enter

NOTE: If any of the numbers are entered incorrectly in the above sequence, the process requires that the default be reset and the program the sequence entered again until it is exactly correct. THIS IS VERY CRITICAL OTHER WISE AN E01 ERROR CAN OCCUR.

Steps to set converter input voltage and frequency response:

The above settings are for maximum torque which will result is a slight vibration between 240-280 rpm, to reduce the vibration at the slight loose of torque rest these parameters:

```
Go into Program "U" (Password:0253) \rightarrow Enter \rightarrow input "1001" \rightarrowEnter \rightarrow input "2040" \rightarrow Enter \rightarrow input "3011" \rightarrowEnter \rightarrow input "4050" \rightarrowDisplay "OVER" \rightarrowEnter
```

Go into Program "U" (Password:0253) → Enter → input "1014" →Enter → input "2050" → Enter → input "3050" →Enter→ input "4225" →Display "OVER" →Enter

- 2. Go into Program "nS" (Password:0253) → Enter → input "2" → Enter
- 3. Go into Program "Sr" (Password:0253) \rightarrow Enter \rightarrow input "1.4" \rightarrow Enter



INSTRUCTION MANUAL

3601 E. 34th St. Tucson, AZ 85713 USA Tel. +1 520-882-6598 Fax +1 520-882-6599 email: pace@metallographic.com Web: http://www.metallographic.com

NANO 1000T/2000T and 1200T with 1 rpm increments (1 and 1.5 hp motor)

Programming Step	Value	Description
SP1	SPEED	Disc Speed - VARIABLE
T1	TIME	Runtime for SP1
SP2 to SP8	200	Multiple step disk speed - DO NOT CHANGE
T2 to T8	0	Runtime for multiple steps - DO NOT CHANGE
Cn	1	Number of cycles – DO NOT CHANGE
SL	100	Disc speed for SPL - preset to 100 rpm
SN	200	Disc speed for SPM - preset to 200 rpm
SH	300	Disc speed for SPH - preset to 300 rpm
DF		Defaults—DO NOT CHANGE
U		SET 110/220V—DO NOT CHANGE
ST	65	Shutoff motor temperature - DO NOT CHANGE
СТ		Current motor temperature - DO NOT CHANGE
CD1	0	Controlled by RUN/STOP button - DO NOT CHANGE 0: Front board control 1: External control of board
CD2	10	Display speed - DO NOT CHANGE 10: Displays speed (rpm) 11: Displays frequency (Hz)
CD3		Motor control method – DO NOT CHANGE
CD4	1000	Max. speed (rpm)
CD5	100	Min. speed (rpm) (do not go below 100 rpm)
CD6	15	Carrier wave value – DO NOT CHANGE